

IN THE CLAIMS:

Please add new Claims 64 and 65 as follows:

~~57~~ ⁶⁴. An electron beam apparatus according to claim

57, wherein said spacer is located on the wire with which said spacer is in electrical contact.

~~65~~ ⁶⁵. An electron beam apparatus according to claim

65, wherein said spacer is located on the wire with which said spacer is in electrical contact.

REMARKS

Claims 57, 58 and 60-65 are presented for consideration. Claim 57 is the sole independent claim.

The claims stand rejected on double patenting grounds as allegedly being unpatentable over Claims 1-38 of U.S. Patent No. 5,594,296. Reconsideration and withdrawal of this rejection is respectfully requested.

Applicants' invention as set forth in the subject claims is directed to an electron beam apparatus comprised of a vacuum envelope containing a plurality of electron-emitting devices, and a plate-shaped spacer capable of forming an electrical connection between a plurality of wires if arranged in electrical contact therewith, with the spacer being in electrical